# **AUTOMATED** OPTICAL INSPECTION

Ō

 $\mathsf{\circ}$ 

SPONSORED BY

- VALERY JEAN (EE)
- JOSEPH SAUCEDA (CPE)

• GARIN ARABACI (EE)

• ANTHONY BADILLO (PSE)

GROUP 1

### MEET THE TEAM









### INTRODUCTION – TECHNOLOGY SUMMARY

- Automated Optical Inspectors (AOIs) are a device that scans small parts on production lines to determine the quality of the product
- **Use high resolution imaging systems**
- Compiles said imagines and determines quality with machine learning and AI
- Higher end systems can use 3-D modeling for a more immersive analysis

### MOTIVATION

- Designing an AOI that is cost efficient that will help the UCF Photonic MOFD Team with their manufacturing Quality Control (QC)
- The product that they are developing is a color changing fabric, with individual copper wires that heat thermochromic pigments
- Operating in the IR range in order to determine if the heat signature from the fabric matches noted patterns that resemble pass/fail patterns
- System will also have an attached laser counter in order to further help the MOFD keep track of the amount of material being used



### GOALS & OBJECTIVES

- Create a device that can take photos at a set rate
- System can process images at the same interval
- System can determine whether the image of the product passes or fails through machine learning
- Laser counter that can keep an accurate count of the fabric material

### ENGINEERING SPECIFICATIONS



### AOI SYSTEM DIAGRAM



- Image of the fabric is captured on the production by our 150 mm frontend optic
- The image is further focused by a 75 mm lens
- The image is then focused and magnified by our camera system with an aperture to help correct most ambient light

### LASER COUNTING SYSTEM



- Our laser is put through a Galilean Beam expander in order to expand the diameter by a rough factor of 3.
- The laser is then focused through a 150 mm Plano Convex lens in order to focus the beam so that it has an appropriate spot size of 50 microns

### OPTICS THEORY – GAUSSIAN BEAM PROPAGATION



•The beam waist and the Depth of Focus can be solved for with the following equations

•Finding the parameters in order to get an ideal value is also possible since the wavelength, diameter, and focal length can be constants

### OPTICS THEORY – GALILEAN BEAM EXPANSION



•To achieve the proper beam diameter for target beam waist and depth of focus, a beam expander is used

•The Galilean Beam Expander is used with a convex and concave lens to increase the diameter by a factor of 3.

•This telescopic methodology is the same process for our camera

### OPTICS HARDWARE

#### Lenses : \$280 from Thorlabs



#### Laser: Procured from MOFD Team





### OPTICS HARDWARE CONT.

- Arducam HQ IR-CUT Camera 12.3MP 1/2.3-In IMX477 w/ 6mm CS Lens for Jetson Nano (\$80)
- FD11A Si Photodiode (2 pack \$32)

### WORK DISTRIBUTION

- Power Supply: Valery Jean
- AOI: Anthony Badillo
- Laser Counter: Anthony Badillo
- Stepper Motor: Garin Arabaci
- Control System PCB: Garin Arabaci
- Image Processing Software: Joseph Sauceda
- Secondary MCU Software: Joseph Sauceda
- Alert Interface (LEDs): Garin Arabaci
- Photodiode RC Filter: Garin Arabaci

# DESIGN **FLOW** DIAGRAM

 $\bigcap$ 

 $\overline{O}$ 

 $\circ$ 

 $\overline{\phantom{0}}$ 





# CONTROL SYSTEM

# **SMICRO SCONTROLLER** UNIT SELECTION

 $\beta$ 





l GPU,

### STEPPER MOTOR FOR AUTO-FOCUSING

- The desired resolution of movement for the auto-focusing system was **0.1mm** minimum.
- Using a belt driven system, with the following parameters we can achieve a resolution of 0.01mm.
	- NEMA17 motor with 200 steps per revolution (Srev)
	- A4988 at 1/16 steps (fm)
	- 2mm pitched belt (p)
	- 16 tooth pulley (Nt)



 $s_{rev} \cdot f_m$ 





### POWER REQUIREMENTS AND PROTECTIONS



- The Jeston will be powered via 3 pins found in its 40 pin jumper. Pins 2 and 4 both accept 5V, but each have a maximum of 2.5A. Pin 6 will be GND.
- In order to protect the Jetson, 2 eFuses will be implemented to restrict the current and voltage that can be delivered to these pins.
- The PICO will be powered via the VSYS pin at 5V.
- As detailed by the PICO's datasheet a Schottky diode is recommended.
	- The same Schottky diode used internally to protect the VBUS pin will be used in this case. Which is a 20V 1A Schottky.





### EFUSES

- The eFuse allows for precision current limiting and overvoltage clamping
- In this case, I made use of the TPS25200 from TI which I configured for exactly 2455.12mA max current limiting. This was accomplished with the following value
	- Rlim  $= 42.2K$  Ohm  $1\%$
	- Cin  $= 0.1$  uF ceramic bypass
	- Cout  $= 20$ uF (using 2 10uF in parallel) low ESR ceramic
- 4 Operational Modes
	- Undervoltage Lockout (UVLO)
	- Overcurrent Protection (OCP)
	- Overvoltage Clamp (OVC)
	- Overvoltage Lockout (OVLO)
- Feature's fault signaling which will be routed to the PICO and is Active-Low. This will trigger for Overcurrent or Overvoltage, or Overtemperature situations.



#### **Specifications**





### PHOTODIODE

#### • THORLABS FD11A

- Reverse biased the diode with 3.3V from the Pico
- RC Low Pass Noise Filter
	- Cutoff Frequency of 1500Hz
- Connects to pin ADC2 of the Pico



B

## CONTROL SYSTEM BLOCK DIAGRAM



11/28/2022 10:24 AM f=2.65 C:\Users\garin\AppData\Local\Temp\Neutron\ElectronFileOutput\15984\sch-0088fc12-6763-4a35-bc82-4f00b483bcd4\Control System Schematic v2.sch (Sheet: 1/1)

# **CONTROL** SYSTEM PCB



# **CONTROL** SYSTEM PCB

![](_page_23_Picture_1.jpeg)

![](_page_24_Figure_0.jpeg)

### POWER CONTROL

Two Types of Power Supply

• AC/DC Converter

• DC/DC Converter

### AC/DC **CONVERTER**

• LM5021 From TI

 $\subset$ 

O

 $\subset$ 

- AC input range 100VAC to 240 VAC
- DC output of 12V, 4A

![](_page_25_Figure_4.jpeg)

 $b^{\frac{1}{2} \bar{\eta} \bar{\eta}}$ 

soowe

י"<br>"אספוני-וו

![](_page_26_Picture_0.jpeg)

#### • AC-DC POWER SUPPLY PCB

### BUCK DC/DC **CONVERTER**

• TPS54561-Q1 from TI

Ò

- Input Voltage range : 7V to 60V
- Output Voltage 5V at 5A

![](_page_27_Figure_4.jpeg)

![](_page_28_Picture_0.jpeg)

![](_page_28_Figure_1.jpeg)

 $\bullet$ 

 $(\ )$ 

![](_page_29_Figure_0.jpeg)

 $\bigcap$ 

 $\bigcap$ 

![](_page_30_Picture_0.jpeg)

 $\bigcap$ 

![](_page_31_Picture_0.jpeg)

### SOFTWARE DESIGN OVERVIEW

![](_page_32_Figure_1.jpeg)

### SOFTWARE TOOLS

# •PYTHON •VISUAL STUDIO CODE •GITHUB

![](_page_33_Picture_2.jpeg)

### IMAGE CAPTURING USING OPENCV

• OPENCV **Extensive Libraries "Optimized for Real-time Applications** • Python Support

• Initial Image Preprocessing

![](_page_34_Picture_3.jpeg)

### IMAGE PRE-PROCESSING (DSP)

**IMAGE** COLOR SEGMENTATION **FILTERING** ADJUSTMENTS PROCESSING ☰ E

**DSP** 

### MACHINE LEARNING BINARY CLASSIFICATION

![](_page_36_Picture_1.jpeg)

![](_page_36_Figure_2.jpeg)

### MACHINE LEARNING MODEL TRAINING

• Train • Test • Evaluate **• Optimize** 

![](_page_37_Figure_2.jpeg)

MACHINE LEARNING ALGORITHM

MACHINE LEARNING ALGORITHM

### ML CLASSIFICATION PROCESS

![](_page_38_Figure_2.jpeg)

- Import Image
- Classify Result
- Improve Model
- Log Outcomes

![](_page_39_Picture_0.jpeg)

### LOGGING, ALERTS AND LASER COUNTER

- Logging Service **Historical Data Store**
- Alerts
	- **ELED System**
	- GUI Interface

![](_page_40_Picture_0.jpeg)

### *Electronics and Power Budget Spending*

![](_page_40_Picture_85.jpeg)

#### *Optics Budget Estimation*

![](_page_40_Picture_86.jpeg)

### PROGRESS

## **Overall Design Progress**

![](_page_41_Figure_2.jpeg)

### ISSUES

- Learning curve to applying each Python Library
	- OpenCV
	- Micropython
	- PyTorch
- Training is time intensive
- Hardware delays
- Camera issues
	- Resolution
	- Framerate

### QUESTIONS?

 $\bigcap$ 

 $\mathbf{O}$